

## Special Issue

# Design, Technology and Test Protocols for Microsystem High Frequency Devices

### Message from the Guest Editors

In this Special Issue, research papers, short communications, and review article contributions are welcome in describing the state-of-the-art for design, technology, and test protocols for high frequency microsystems. Keywords

- MEMS
- NEMS
- microwaves
- millimeter waves

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### Guest Editors

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Dr. Emanuela Proietti

Dr. Giovanni Maria Sardi

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### Deadline for manuscript submissions

closed (31 October 2020)



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